

PTO-1449 Information Disclosure Citation in an Application				Application No.		Applicant(s)			
				10/735,477		David C. Hovda			
				Docket Number		Group Art Unit		Filing Date	
				S-16		3739		December 11, 2003	
U.S. PATENT DOCUMENTS									
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE		
/MP/	A.	5,098,431	03/24/92	Rydell	606	48	07/03/90		
	B.	5,122,138	06/16/92	Manwaring	606	46	11/28/90		
	C.	5,417,687	05/23/95	Nardella et al.	606	32	04/30/93		
	A.	6,261,286	07/17/01	Goble et al.	606	34	10/16/98		
	B.	6,261,311	07/17/01	Sharkey et al.	607	96	7/30/99		
	C.	6,264,652	07/24/01	Eggers et al.	606	41	05/18/99		
	D.	6,277,112	08/21/01	Underwood et al.	606	32	02/20/98		
	E.	6,280,441	08/28/01	Ryan	606	45	12/15/97		
	A.	6,749,604	06/15/04	Eggers et al.	606	41	03/30/00		
	B.	6,770,071	8/3/2004	Woloszko et al.	606	41	2/9/2001		
	C.	6,837,887	1/4/2005	Woloszko et al.	606	41	1/25/2002		
	D.	6,837,888	1/4/2005	Ciarrocca et al.	606	41	2/25/2002		
	A.	7,169,143	01/30/07	Eggers et al.	606	32	10/20/05		
	B.	7,179,255	02/20/07	Lettice et al.	606	32	12/20/00		
	C.	7,186,234	03/06/07	Dahla et al.	604	22	02/05/02		
	D.	7,192,428	03/20/07	Eggers et al.	606	41	03/20/03		
	E.	7,201,750	04/10/07	Eggers et al.	606	41	05/18/99		
	F.	7,217,268	05/15/07	Eggers et al.	606	32	06/24/03		
	G.	4,573,448	3/4/86	Kambin	606	170	10/5/1983		
	H.	5,207,684	5/4/93	Nobles	606	108	4/13/1992		
	I.	5,571,189	11/5/96	Kuslich	623	17.12	5/20/1994		
	J.	5,877,289	3/2/99	Thorpe et al.	530	387.7	6/7/1995		
	K.	6,093,187	7/25/00	Lecuyer	606	45	3/31/1998		
	L.	6,746,451	6/8/04	Middleton et al.	606	79	6/1/2001		
✓	M.	6,761,718	7/13/04	Madsen	606	50	9/6/2001		
/MP/	N.	7,108,696	9/19/06	Daniel et al.	606	41	9/22/2003		
EXAMINER					DATE CONSIDERED				
/Michael Peffley/					11/01/2007				
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/MP/	A.	2003/0014047	1/16/2003	Woloszko et al.	606	41	6/18/2002
/MP/	B.	2002/0029036	03/07/02	Goble et al.	606	38	08/09/01
/MP/	C.	2002/0095151	07/18/02	Dahla et al.	606	41	02/05/02
/MP/	D.	2005/0234439	10/20/05	Underwood et al.	606	032	03/25/05
/MP/	E.	2005/0251134	11/10/05	Woloszko et al.	606	032	05/09/05
/MP/	F.	2006/0095031	05/04/06	Ormsby, T.	606	034	09/22/05
/MP/	G.	2006/0129145	06/15/06	Ormsby et al.	606	041	10/11/05
/MP/	H.	2006/0178670	08/10/06	Woloszko et al.	606	048	01/17/06
/MP/	I.	2006/0189971	08/24/06	Eggers et al.	606	032	11/23/05
/MP/	J.	2006/0253117	11/09/06	Hovda et al.	128	898	03/09/06
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
/MP/	A.	05/000434	12/20/06	NL	---	---	X
/MP/	B.	05/125287	12/29/05	WO	A61B	18/00	X
NON-PATENT DOCUMENTS							
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
	A.	AESCULAP, "Flexible endoscope", Micro, Neuro and Spine surgery, 3 pgs					06/18-21/2002
/MP/	B.	Stoffels, E. et al., "Investigation on the Interaction Plasma-Bone Tissue", E-MRS Spring Meeting, 1 pg					06/18-21/2002
/MP/	C.	Stoffels, E. et al., "Biomedical Applications of Plasmas", Tutorial presented prior to the 55 th Gaseous Electronics Conference in Minneapolis, MN, 41 pgs					10/14/02
/MP/	D.	Stoffels, E. et al., "Plasma Interactions with Living Cells", Eindhoven University of Technology, 1 pg					2002
/MP/	E.	Stoffels, E. et al., "Superficial Treatment of Mammalian Cells using Plasma Needle", J. Phys. D: Appl. Phys. 26, pp. 2908-2913					11/19/03
/MP/	F.	Stoffels, E. et al., "Plasma Needle", Eindhoven University of Technology, 1 pg					11/28/03
/MP/	G.	Stoffels, E. et al., "Plasma Physicists Move into Medicine", Physicsweb, 1 pg					11/2003
/MP/	H.	Stoffels, E. et al., "Plasma Treated Tissue Engineered Skin to Study Skin Damage", Biomechanics and Tissue Engineering, Materials Technology, 1 pg					2003
EXAMINER /Michael Peffley/					DATE CONSIDERED 11/01/2007		
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/MP/	A.	Stoffels, E. et al., "Plasma Treatment of Dental Cavities: A Feasibility Study", IEEE Transaction on Plasma Science, Vol. 32, No. 4, pp. 1540-1542		08/2004
/MP/	B.	Stoffels, E. et al., "The Effects of UV Irradiation and Gas Plasma Treatment on Living Mammalian Cells and Bacteria: A Comparative Approach", IEEE Transaction on Plasma Science, Vol. 32, No. 4, pp. 1544-1550		08/2004
/MP/	C.	Stoffels, E. et al., "Electrical and Optical Characterization of the Plasma Needle", New Journal of Physics 6, pp. 1-14		10/28/04
/MP/	D.	Stoffels, E. et al., "Where Plasma Meets Plasma", Eindhoven University of Technology, 23 pgs		2004
/MP/	E.	Stoffels, E. et al., "Gas Plasma effects on Living Cells", Physica Scripta, T107, pp. 79-82		2004
/MP/	F.	Stoffels, E. et al., "Plasma Treatment of Mammalian Vascular Cells: A Quantitative Description", IEEE Transaction on Plasma Science, Vol. 33, No. 2, pp. 771-775		04/2005
/MP/	G.	Stoffels, E. et al., "Deactivation of Escherichia Coli by the Plasma Needle", J. Phys. D: Appl. Phys. 38, pp. 1716-1721		05/20/05
/MP/	H.	Stoffels, E. et al., "Development of a Gas Plasma Catheter for Gas Plasma Surgery", XXVIIIth ICPIG, Eindhoven University of Technology, pp. 18-22		07/2005
/MP/	I.	Stoffels, E. et al., "Development of a Smart Positioning Sensor for the Plasma Needle", Plasma Sources Sci. Technol. 15, pp. 582-589		06/27/06
/MP/	J.	Stoffels, E. et al., "Killing of S. Mutans Bacteria Using a Plasma Needle at Atmospheric Pressure, IEEE Transaction on Plasma Science, Vol. 34, No. 4, pp. 1317-1324		08/2006
/MP/	K.	Stoffels, E. et al., "Plasma-Needle Treatment of Substrates with Respect to Wettability and Growth of Excherichia Coli and Streptococcus Mutans", IEEE Transaction on Plasma Science, Vol. 34, No. 4, pp. 1325-1330		08/2006
/MP/	L.	Stoffels, E. et al., "Reattachment and Apoptosis after Plasma-Needle Treatment of Cultured Cells", IEEE Transaction on Plasma Science, Vol. 34, No. 4, pp. 1331-1336		08/2006
/MP/	M.	Stoffels, E. et al., "UV Excimer Lamp Irradiation of Fibroblasts: The Influence on Antioxidant Homostasis", IEEE Transaction on Plasma Science, Vol. 34, No. 4, pp. 1359-1364		08/2006
/MP/	N.	Stoffels, E. et al., "Plasma Needle for In Vivo Medical Treatment: Recent Developments and Perspectives", Plasma Sources Sci. Technol. 15, pp. S169-S180		10/06/06
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